

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/118,359
Filing Date July 17, 1998
Inventor J. Dennis Keller et al.
Assignee Micron Technology, Inc.
Group Art Unit 2823
Examiner Michelle Estrada
Attorney's Docket No. MI22-587
Title: Methods of Forming Floating Gate Transistors

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References –See Attached Form PTO-1449

The attached Form PTO-1449 is submitted in compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98. Pursuant to Federal Register Vol. 69, No. 182, pg. 56542 (September 21, 2004), no copies of any cited U.S. patents or U.S. published applications are included herewith. No admission is made regarding whether the submitted references are prior art.

This Supplemental Information Disclosure Statement is being filed after receipt of a Notice of Allowance. Therefore, no fee is believed to be required. However, in the event that a fee is required, please charge the fee specified under 37 C.F.R. § 1.17(p) to Deposit Account No. 23-0925.

Citation of these references is respectfully requested.

Respectfully submitted,

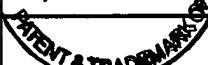
Dated: 3/10/06

By:



Robert C. Hyta
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09/118,359U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEAPPLICANT
J. Dennis Keller, et al.LIST OF ART CITED BY APPLICANT
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July 17, 1998GROUP
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U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	4,249,968	02/1981	Gardiner, et al.			
	AB	5,147,813	09/1992	Woo			
	AC	5,289,026	02/1994	Ong			
	AD	5,439,838	08/1995	Yang			
	AE	5,445,982	08/1995	Hwang			
	AF						
	AG						
	AH						
	AI						
	AJ						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Clas s	Subcl ass	Translation	
							Yes	No
	AK							
	AL							
	AM							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

	AN	
	AO	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.